Quantum Transport Simulation of the DOS function, Self-Consistent Fields and Mobility in MOS Inversion Layers*

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We describe a simulation of the self-consistent fields and mobility in (100) Si-inversion layers for arbitrary inversion charge densities and temperatures. A nonequilibrium Green's functions formalism is employed for the state broadening and conductivity. The subband structure of the inversion layer electrons is calculated self-consistently by simultaneously solving the Schrödinger, Poisson and Dyson equations. The self-energy contributions from the various scattering mechanisms are calculated within the self-consistent Born approximation. Screening is treated within RPA. Simulation results suggest that the proposed theoretical model gives mobilities which are in excellent agreement with the experimental data.

Keywords: Green's functions, mobility, inversion layers, surface-roughness, broadening of the states.

The inversion layer mobility in Si MOSFET is a very important physical quantity that describes the drain current and also serves as a probe to study the electronic transport properties of the quasi-two-dimensional (Q2D) electron gas. Semi-empirical models have been developed to explain the overall mobility behavior at various temperatures and different gate voltages [1,2]. Monte Carlo studies of the two-dimensional electron transport in Si MOS devices have also been performed [3]. However, scaling of the MOS device downwards leads to high surface fields. Then, the degenerate nature of the electrons dominates the transport properties of the structure. The Fermi-Dirac statistics influence the mobility in two ways: through the screening properties of the electron gas and through the distribution function itself. In addition, broadening of the states near the subband thresholds impacts the redistribution of the carriers among various subbands. To overcome some of the limitations of previous theories, we use a new theoretical model in which the two-dimensional aspects of carrier motion, intersubband transitions, the anisotropy of the acoustic phonon interaction, as well as the broadening of the electronic states and the degenerate nature of the Q2D electron gas are simultaneously taken into account.

The theoretical model is summarized in Fig. 1. The initial potential energy profile is calculated analytically using a variational approach for the electronic quantum limit. The Schrödinger, Poisson and Dyson equations are then iterated for the corresponding unknowns [4], and self-consistency is achieved through the outer iteration. For each iteration, the one-dimensional Schrödinger equation is integrated leftward ($\psi_l^n$) and rightward ($\psi_r^n$) using a 1D version of the Numerov algorithm [5]. The effective

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Solve the Poisson equation for the Hartree potential.

Calculate the initial potential energy profile using variational approach.

Evaluate the subband structure (solve the Schrödinger equation).

Calculate wavevector-dependent matrix elements for all scattering processes.

Calculate screened matrix elements for surface-roughness and Coulomb scattering.

Evaluate one-electron properties of the system (excitation spectrum, broadening of the states, spectral density function, and DOS function).

Calculate zero-temperature and finite-temperature conductivity (mobility).

Compare subband separation results with FIR optical absorption experiments.

Compare with experimental measurements of effective or Hall mobility.

FIGURE 1 Flow-chart of the model

The potential energy consists of the sum of the Hartree, image and exchange-correlation terms [6]. The two solutions are matched at the turning point and an eigenvalue is indicated by the continuity of the logarithmic derivative at the matching point, i.e. when the matching tolerance $f = \frac{[\psi_n^e(z_m - h) - \psi_n^e(z_m + h)]}{\psi_n^e(z_m)}$, where $h$ is the mesh size in the confining direction, is less than $5 \times 10^{-5}$. A simple eigenvalue search is used until $f$ is a monotonically decreasing or increasing function and a bisection method is employed within the energy interval that contains an eigenvalue.

The wavevector-dependent matrix elements are next found for Coulomb scattering from depletion layer and/or oxide/interface charges, surface-roughness scattering and scattering from the various modes of lattice vibrations (acoustic and zero- and first-order nonpolar optical phonons) [4,7]. Screened matrix elements for Coulomb and surface-roughness scattering are calculated using the Random Phase Approximation (RPA). Due to the loss of translational invariance in the confining direction, the dielectric function for a Q2D system becomes a fourth rank tensor which requires inversion of a $N \times N$ matrix. For (100) silicon, the size of this matrix is precisely $N = n_1^2 + n_2^2$ where $n_1$ ($n_2$) is the number of subbands from the first (second) set of equivalent valleys with heavy (light) mass perpendicular to the interface. We first evaluate the diagonal (intrasubband) terms of the screened scattering potentials from the bare ones by inverting the linear problem

$$W_{ii}^{\text{eff}}(q, \omega) = \psi_{ii}^{\text{bare}}(q) + \frac{1}{q} \sum_n F_{ii,nn}(q) q_{nn}(q, \omega) W_{nn}^{\text{eff}}(q, \omega), \quad (1 \text{a})$$

where $F_{ij,nn}(q)$ are the form-factors due to the finite extent of the electron gas in the confining direction and $q_{nn}(q, \omega)$ are the screening wavevectors [4]. The off-diagonal (intersubband) terms are then obtained from

$$W_{ij}^{\text{eff}}(q, \omega) = \psi_{ij}^{\text{bare}}(q) + \frac{1}{q} \sum_n F_{ij,nn}(q) q_{nn}(q, \omega) W_{nn}^{\text{eff}}(q, \omega). \quad (1b)$$

Since the matrix elements for Coulomb scattering decrease rapidly with the wavevector, a nonuniform mesh in momentum space is generated with the coordi-
quantum transformation $q_{\text{new}} = q_{\text{old}}^2 / (q_{\text{old}} + a)$, where
$q_{\text{old}}$ is a wavevector on the uniform mesh, $q_{\text{new}}$ is the corresponding one on the nonuniform mesh and $a = 2 \times 10^9 \text{ m}^{-1}$ is an adjustable parameter. In the second step, we evaluate frequency and kinetic energy dependent scattering-induced broadening of the states [4]

$$
\Gamma_n(\varepsilon_k, \omega) = \sum_{m} \frac{m^*}{4\pi^2 \hbar^2} \int_{0}^{\infty} d\varepsilon_q \left[ \frac{\Gamma_m(\varepsilon_q, \omega)}{\hbar \omega - \varepsilon_q - \varepsilon_m} + \Gamma^2_m(\varepsilon_q, \omega) \right]^{2\pi} d\vartheta T_{nm}(\varepsilon_k - \varepsilon_q),
$$

(2)

where $T_{nm}(\varepsilon_k - \varepsilon_q)$ is the sum of the squared matrix elements of all scattering processes. The first Born approximation results are used as an initial guess in this iterative procedure. Once the system of integral equations (2) is solved, we proceed with the calculation of the density of states (DOS) functions. If self-consistency is not achieved, we proceed with the solution of the Poisson equation for which we use the approach given in [6] to find the improved Hartree potential. The potential energy profile for the next iteration is obtained by using a fixed-convergence factor scheme for the first two iterations and an extrapolated convergence-factor scheme thereafter. The error criterion for the convergence of the self-consistent field iterations is that the absolute value of the difference between the input and output potentials at each grid point is less than 0.01 meV.

After achieving self-consistency, we iteratively solve the system of Fredholm integral equations (that result from the full Bethe-Salpeter equation)

$$
\Lambda_n(\varepsilon_k, \omega) = 1 + \sum_{m} \frac{k \cdot q}{k^2} T_{nm}(k - q)
\frac{\lambda_m(\varepsilon_q, \omega)}{2\pi \lambda_m(\varepsilon_q, \omega)} \Lambda_n(\varepsilon_q, \omega)
$$

(3)

for the kernel functions $\Lambda_n(\varepsilon_k, \omega)$ which appear in the expression for the dc-conductivity

$$
\sigma_{2D} = \frac{2e^2}{h} \sum_{n} \int d\omega \left( - \frac{\partial \nu_F}{\partial \omega} \right)
\int_{0}^{\infty} \frac{d\varepsilon_k}{2\pi} \varepsilon_k \Lambda_n(\varepsilon_k, \omega) \frac{\lambda_n(\varepsilon_k, \omega)}{2\pi \lambda_n(\varepsilon_k, \omega)},
$$

(4)

where $n_F(\omega)$ is the Fermi-Dirac distribution function. The average or effective mobility is then calculated from $\mu_{\text{eff}} = \sigma_{2D} / eN_s$, where $N_s$ is the total sheet-charge density.

The mobility is shown in Fig. 2 and compared with experimental data from n-channel MOSFET’s fabricated on (100) Si wafers. The filled circles and open triangles represent the experimental mobilities for devices with $N_s = 2 \times 10^{16} \text{ cm}^{-2}$ and $N_s = 7.2 \times 10^{16} \text{ cm}^{-2}$, respectively [8]. The solid and dashed lines are the corresponding simulation results. For both devices, the interface-trap density is estimated to be $N_{it} = 1.75 \times 10^{11} \text{ cm}^{-2}$. Coupling constants for deformation potential and non-polar optical phonon scattering (zero- and first-order interactions) and the corresponding phonon energies, used in the calculations, are given in Refs. [3,9]. Very good agreement between the experimental data and the simulation results throughout the whole inversion charge density region can be observed. The small discrepancy at low values of $N_s$ ($N_s < 5 \times 10^{11} \text{ cm}^{-2}$) might be due to the following two reasons: (1) the application of finite drain voltage leads to a decrease in the carrier concentration near the drain causing a lower value for the experimental mobility; (2) a three subband approximation ($n_1 = 2$ and $n_2 = 1$), used at present, overestimates the mobility in the low inversion-charge density region where a small fraction of the inversion layer electrons actually resides in the higher-lying subbands.
Present simulation results suggest that, even at room temperature, Coulomb scattering from interface-trap and depletion layer charges degrades the mobility at low surface fields. The proper treatment of the anisotropy of the deformation potential interaction at \( T = 300 \text{ K} \) leads to mobilities that are in close agreement with the experimental data in the range of low-to-medium densities \( (\approx 10^{11} - 10^{12} \text{ cm}^{-2}) \), where acoustic phonon scattering limits the mobility. We also find that the importance of surface-roughness scattering shifts toward higher surface fields with increasing temperature. In order to explain the experimental data of Takagi et al. [8] at high surface fields, temperature-dependent roughness parameters have been adopted. In other words, good agreement with the experimental data is achieved by using an exponential model for the autocovariance function with \( \Delta = 0.3 \text{ nm} \) \( (\Delta = 0.25 \text{ nm}) \) and \( \zeta = 1.5 \text{ nm} \) \( (\zeta = 1.4 \text{ nm}) \) at \( T = 300 \text{ K} \) \( (T = 77 \text{ K}) \), as well as the Ando model [6] for the surface-roughness matrix element. These roughness dimensions are comparable to the TEM results obtained by Goodnick et al. [10].

The shape of the cumulative DOS function for the device with \( N_s = 2 \times 10^{16} \text{ cm}^{-3} \) is shown in Fig. 3. For low values of \( N_s \) \( (\approx N_{s1}) \), strong Coulomb scattering and small subband separation eliminates plateau regions in the DOS curve. The steeper rise of the DOS curve near subband thresholds for \( N_s = N_{s2} \) is a consequence of the decreased importance of Coulomb scattering. At higher values of \( N_s \) \( (= N_{s3}) \), the increased subband separation and reduced intersubband scattering allows the plateau regions in the DOS curves to be observed.

In conclusion, simulation results for the mobility suggest that the theoretical model correctly predicts both the order of magnitude and the overall mobility behavior at various temperatures. We also find that for energies near the subband thresholds, the broadening of the states is comparable to the kinetic energy of the carriers. This leads to modification of the DOS function from its ideal step-like behavior and influences the population of various subbands which, in turn, modifies the mobility.

References

Biographies
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